

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hajime YAMAMOTO et al.**

Art Unit: **1722**

Application Number: **10/647,247**

Examiner: **Daborah Chacko Davis**

Filed: **August 26, 2003**

Confirmation Number: **1773**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND  
METHOD OF FORMING RESIST PATTERN**

Attorney Docket Number: **031029**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.114**

**Mail Stop: RCE**

January 7, 2011

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This Amendment is being filed concurrently with a Request for Continued Examination pursuant to 37 C.F.R. §1.114, and in response to the Final Office Action dated October 12, 2010.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 10 of this paper.